

Claims

- 1. A negative aqueous photoresist composition, comprising:
- a) a polymer comprising at least one unit with structure (1)

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where R_1 is hydrogen or (C_1-C_4) alkyl and n = 1-4;

- b) a water-soluble photoactive compound;
- c) a crosslinking agent; and,
- d) a solvent composition.

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2. The photoresist composition according to claim 1, where the photoactive compound has structure (2),

 $(R_2)_{\overline{M}}$ OCH₃ (2)

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where,

R₂ is hydrogen, alkyl, -O(alkyl), -(alkyl)OH, hydroxyphenyl or multihydroxyphenyl,

R₃ and R₄ are independently (C₁-C₄) alkyl,

m = 1-3, and,

X is an anion.

- 3. The photoresist composition according to claim 1, where solvent composition is water or a mixture of water and a (C_1-C_4) alkyl alcohol.
 - 4. The photoresist composition according to claim 1, where the polymer contains additional nonaromatic units.

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- 5. The photoresist composition according to claim 4, where the nonaromatic units are selected from a group consisting of ethylenic alcohol, ethylenic pyrollidone, ethylenic acetate, and methylene alcohol.
- 6. The photoresist composition according to claim 1, where the polymer contains at least 10 mole% of the unit of structure 1.
- 7. The photoresist composition according to claim 1, where n = 1 and R_1 is selected from methyl, ethyl, propyl and butyl.
 - 8. The photoresist composition according to claim 2, where the photoactive compound is (4-methoxyphenyl)dimethylsufonium trifluoromethanesulfonate.
- 15 9. The photoresist composition according to claim 1, where the crosslinker is selected from melamine resins, urea resins and glycolurils.
 - 10. The photoresist composition according to claim 3, where the alcohol is isopropanol.
 - 11. A process for imaging a negative photoresist comprising the steps of:
 - a) forming on a substrate a photoresist coating from the photoresist composition of claim1;
 - b) image-wise exposing the photoresist coating;
- 25 c) postexposure baking the photoresist coating; and
 - d) developing the photoresist coating with a developer.
 - 12. The process of claim 11, where the image-wise exposure wavelength is below 260nm.
 - 13. The process according to claim 11, where the developer is selected from water, a mixture of water and a (C_1-C_4) alkyl alcohol, mixture of water and surfactant, and an aqueous base solution.

14. The process according to claim 13, where the alcohol is isopropanol.